



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of: **Hidemasa KAI et al.**

Art Unit: **1763**

Application Number: **10/626,675**

Examiner: **Ram N. Kackar**

Filed: **July 25, 2003**

Confirmation Number: **1831**

For: **EPITAXIAL WAFER PRODUCTION APPARATUS AND SUSCEPTOR
STRUCTURE**

Attorney Docket Number: **030901**

Customer Number: **38834**

RESPONSE UNDER 37 C.F.R. § 1.111

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

March 5, 2008

Sir:

In response to the Office Action dated September 5, 2007, the response date of which is herein extended by three (3) months to March 5, 2008 with a concurrently filed Petition for a (3) Month Extension of Time, Applicant herein amends the claims and submits the following remarks.

Amendments to the Claims begin on page 2 of this paper.

Remarks begin on page 7 of this paper.